

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|---|------------------|---------|------------------|
| L1 | 1482 | 349/42 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/07/10 23:30 |
| L2 | 1704 | 349/43 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/07/10 23:30 |
| L3 | 2456 | 1 2 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/07/10 23:30 |
| L4 | 268 | 3 and substrate and (semiconductor or active or amorphous) and ohmic and pixel and (gate or scan\$4) and drain and source and (insulat\$4 or passivation) and pad | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/07/10 23:32 |
| L5 | 237 | 4 and hole | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/07/10 23:34 |
| L6 | 93 | 5 and (reduc\$5 near3 resistance) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/07/10 23:36 |
| L7 | 74 | 5 and ((reduc\$5 near3 resistance) near9 (contact or pad)) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/07/10 23:40 |
| L8 | 177 | 5 and ((storage or capacit\$5) or ((storage or capacit\$5) near3 (layer or electrode or film))) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/07/10 23:41 |
| L9 | 110 | 5 and (((storage or capacit\$5) or ((storage or capacit\$5) near3 (layer or electrode or film)))) same hole) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/07/10 23:44 |
| L10 | 112 | 5 and (((metal near2 pattern) (storage or capacit\$5) ((storage or capacit\$5) near3 (layer electrode film)))) same hole) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2005/07/10 23:45 |

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|----|------|--|---|----|----|------------------|
| S1 | 1174 | 349/43 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2003/07/10 15:52 |
| S2 | 1100 | ((liquid near2 crystal near2 display) or lcd) and substrate and 349/43 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2003/07/10 16:02 |
| S3 | 895 | ((((liquid near2 crystal near2 display) or lcd) and substrate and 349/43) and semiconductor | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2003/07/10 16:05 |
| S4 | 859 | (((((liquid near2 crystal near2 display) or lcd) and substrate and 349/43) and semiconductor) and (al or aluminum) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2003/07/10 16:06 |
| S5 | 651 | ((((((liquid near2 crystal near2 display) or lcd) and substrate and 349/43) and semiconductor) and (al or aluminum)) and transparent and (mo or molybdenum or ni or nickel or cr or chromium or cu or copper or ag or silver or pb or lead) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2003/07/11 07:22 |
| S6 | 651 | ((((((liquid near2 crystal near2 display) or lcd) and substrate and 349/43) and semiconductor) and (al or aluminum)) and transparent and (mo or molybdenum or ni or nickel or cr or chromium or cu or copper or ag or silver or pb or lead) | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2003/07/11 07:42 |
| S7 | 178 | ((((((((liquid near2 crystal near2 display) or lcd) and substrate and 349/43) and semiconductor) and (al or aluminum)) and transparent and (mo or molybdenum or ni or nickel or cr or chromium or cu or copper or ag or silver or pb or lead)) and (gate near6 (aluminum or al)) and (pixel near6 transparent) and source and drain and insulat\$5 | US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB | OR | ON | 2003/07/11 07:52 |